

compass 2°

Specifications

System	
Measurement Technique	Non-contact, three-dimensional, coherence scanning interferometry with field stitching
Applications	Optical surface form and texture; optical surface deviation from design; relational metrology of mechanical and datum features
Scanner	Closed-loop piezo-based, with highly linear capacitive sensors
Objectives	2.5X for relational / 20X for surface (typ); 10X and 50X optional for surface; See the Nexview & NewView Series Objective Chart for more details
Objective Mounting	Motorized 4-position turret
Field Zoom Lenses	Motorized 3-position encoded zoom • 0.5X, 0.75X, 1.5X included
Field of View	Objective and zoom selectable
Illuminator	Single white-light LED with long life, uniform imaging and high efficiency
Measurement Array	Selectable: 1408 x 1408, 1024 x 1024
Z-Drive (Focus) Stage	100 mm range with 0.1 μ m resolution
Part Stage	5-axis containing X, Y, Pitch, B, C,
Sample Holder	Vacuum Chuck for flat base pin tooling and Universal adhesive lens holder included
Vibration Isolation	3D pneumatic isolation legs included Active solution optional
PHYSICAL	
Dimensions (HWD)	System & encl: ~160 x 116 x 106 cm Electronics Rack: ~138 x 61 x 96 cm Typ. Footprint (WD): 185 x 172 cm
Weight	System & Encl: 820 kg
	Electronics Rack: 76 kg
UTILITY REQUIREMENTS	
Input Voltage	100 to 240 VAC, 50/60 Hz
Compressed Air for Table	4.1 to 5.5 bar (60 to 80 psi); dry and filtered; 6 mm OD hose input
ENVIRONMENTAL REQUIREMENTS	
Temperature	20 to 23°C with +/- 0.1°C stability *required for performance to specification
Temperature Change	<0.2°C per hr and <1°C per 24 hr *maximum allowed thermal change
Humidity	5 to 95% relative, noncondensing
Floor / Acoustic Vibration limits	VC-C or better / NC-30 or better
TEST PART CHARACTERISTICS	
Sample Types	High-precision glass or plastic injection
	molded lenses and optical devices,
	diamond-turned molds. with a CA < 8 mm
	for form and CA < 6.4 mm for relational
Material	Uncoated metal, glass, and plastic w/ reflectivity between 0.05% - 100%
Geometries	Continuous and rotationally symmetric



PERFORMANCE	
Specification Description	Target performance 1σ reproducibility
Aspheric Surface Form Error	0.010 µm (RMS), 0.030 µm (PV)
Aspheric Surface Roughness	0.005 μm (Sa)
Lens Height	0.17 μm
Tilt Control Interlock Flatness	0.02 µm
Side1- Side2 Concentricity	0.1 µm
A1-A2 Concentricity	0.25 μm
Lens Concentricity to Interlock	0.16 µm
Interlock Diameter	0.05 μm
Thickness at Center	0.34 μm
Tilt Control Interlock Parallelism	10 arc sec
Tilt Control Interlock Thickness	0.24 µm
MEASUREMENT MODES	
3D Form & Texture	 Full area topography, waviness, and texture (tooling marks, artifacts, etc.) measurement defined by: OpticStudio & CODE V prescription
	Unknown surface tracking
Form Deviation	Full area deviation map when lens is measured using a surface equation
Production Form Deviation Mode	Ring-spoke form deviation method for increased throughput with reduced data density
Relational	Flatness, thickness, and centration of lens surface to mechanical datums. Capability is surface dependent
FOOTNOTE	

Performance specifications under laboratory conditions using standard specimens, according to ISO 25178-601, 25178-604 and 5436-1.

Specifications subject to change without prior notice.

SS-0134 08/22 © 2022 Zygo Corporation. All rights reserved.

spheres, gullwings, pancakes, and other

asphere shapes plus freeforms



compass 2°

Specifications



TYPICAL TOOL LAYOUT



Ø115.00

Dimensions in mm A customer reference drawing is available upon request